We claim:

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1 1. A method for fabricating a tapered optical coupling into a slab waveguide 2 comprising: 3 providing a sputtering source; providing at least one mask between said source and said mask; 4 5 disposing a tapered layer of material onto a substrate which includes a 6 waveguiding layer by means of shadow deposition defined by said sputtering source <u>| 4</u>7 and said at least one mask, said tapered layer extending in a first two dimensional plane and optically coupled to said waveguiding layer; and photolithographically defining a second taper in said tapered layer, said second taper extending in a second two dimensional plane intersecting said first two dimensional plane.

- 2. The method of claim 1 where photolithographically defining a second taper in said tapered layer defines said second two dimensional plane so as to perpendicularly intersect said first two dimensional plane.
- The method of claim 1 further comprising photolithographically defining a slab
 waveguide in said waveguiding layer simultaneously with photolithographically
 defining a second taper in said tapered layer.

- 1 5. The method of claim 4 where coupling said slab waveguide to said photonic crystal comprises forming said slab waveguide integrally with said photonic crystal. 2
- 6. The method of claim 1 where disposing said tapered layer of material onto said 1 2 substrate comprises disposing said tapered layer by means of shadow deposition 3 defined by said sputtering source and said at least two masks.
 - 7. The method of claim 1 where disposing said tapered layer of material onto said substrate comprises disposing polycrystalline silicon.
 - 8. The method of claim 1 where disposing said tapered layer of material onto said substrate comprises disposing a material with an approximately matching refractive index to said waveguiding layer.

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9. The method of claim 1 further comprising repeating said method on an opposing 1 2 side of said substrate to form another tapered optical coupling on said opposing side 3 aligned with said tapered optical coupling.

- 1 10. The method of claim 1 further comprising first forming a tapered substrate 2 by means of shadow deposition and then forming said tapered optical coupling on 3 said tapered substrate to obtain a fully flared, funnel-shaped, optical coupling.
- 1 11 A tapered optical coupling comprising:
- 2 a substrate;

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- a slab waveguide on or in said substrate; and
- a funnel-shaped termination on or in said substrate and optically coupled to said slab waveguide.
 - 12. The apparatus of claim 11 further comprising a photonic crystal and where said photonic crystal is optically coupled to said slab waveguide.
 - 13. The apparatus of claim 12 where said slab waveguide is integral with said photonic crystal.
- 1 14. The apparatus of claim 11 further comprising an optic fiber and where said 2 funnel-shaped termination is optically coupled to said optic fiber.
- 1 15. The apparatus of claim 11 where said funnel-shaped termination is formed
 2 by shadow deposition.

- 1 16. The apparatus of claim 11 where said funnel-shaped termination is
 2 composed of material having an index of refraction approximately matching said slab
- 3 waveguide.

- 1 17. The apparatus of claim 16 where said funnel-shaped termination is composed of polycrystalline silicon.
- 1 18. The apparatus of claim 17 where said slab waveguide is composed of 2 GaAs.
- The apparatus of claim 11 where said funnel-shaped termination is a half
 funnel shape.
 - 20. The apparatus of claim 11 where said funnel-shaped termination is a full-funnel shape.
 - 1 21. The apparatus of claim 11 where said funnel-shaped termination 2 comprises a surface for optical coupling inclined with respect to said substrate.